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520.34403CV4

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

420

Applicant(s): T. MASUDA, et al

Serial No.:

09/421,043

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PLASMA PROCESSING APPARATUS AND PLASMA

PROCESSING METHOD

Group:

1765

Examiner:

D. Deo

## UNDER 37 CFR 1.97 & 1.98

Commissioner for Patents Washington, D.C. 20231

May 14, 2002

Sir:

In the matter of the above-identified application, applicant(s) is/are submitting herewith a copy of documents listed in the attached form equivalent to Form PTO-1449 for the Examiner's consideration.

This information disclosure statement is being submitted before the mailing date of a notice of allowance and is accompanied by the fee of \$180.00 set forth in 37 CFR 1.17(p).

To the extent that, the documents listed on the attached form equivalent to Form PTO-1449, are not in the English language, the requirement of 37 CFR 1.98(a)(3) for a concise explanation of the relevance is satisfied by an English language abstract or corresponding U.S. patent of the document.

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It is respectfully requested that this information disclosure statement be considered by the Examiner.

Please charge any shortage in the fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account No. 01-2135 (520.34403CV4) and please credit any excess fees to such deposit account.

Respectfully submitted,

Melvin Kraus

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